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ORIGINAL PAPER

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Study on stress evolution in the cooling process of micro hot embossing

Juan A Gomez¹, Devanda Lek², In-Hyouk Song^{1,2} and Byoung Hee You^{1,2*}

Abstract

Cooling of an embossed part has been recognized as one of the critical steps in the hot embossing of polymer microdevices. Numerical analysis was performed to study the stress developed in an embossed microstructure during the cooling process of hot embossing. A hemisphere-tipped post was selected as an example structure to demonstrate the stress evolution. The posts are located at 5, 10, 15, and 20 mm from the center of the embossed part. The results of the analysis showed that stresses of the posts increased as the radial locations of the post increased. In addition, the stress rapidly increased until the cooling time reached about 100.0 s. The maximum stresses of 28.9, 30.2, 32.3, and 34.5 MPa were estimated at the post locations of 5, 10, 15, and 20 mm from the center of the part, respectively. Experiments were performed to verify the numerical models. Undercut at the bottom of a post was observed as it was predicted in the numerical analysis.

Keywords: Cooling; Micro hot embossing; Stress evolution; Shrinkage; Stress concentration

Review

Cooling of a molded part is a critical step for the successful fabrication of polymer microstructures using hot embossing (Matthew and David 2011; Song et al. 2008a; Jeong et al. 2002). Defects not caused by the filling of the mold cavity with polymer are attributed to the cooling or demolding process (Song et al. 2008a; Jeong et al. 2002; Guo et al. 2007a, b). Typical cooling defects include distorted, deformed, and broken microstructures. The shrinkage of polymer induces thermal stress in the molded part as it cools down. Thermally induced mechanical stress is a principal contributor to the defects (Song et al. 2008b; Worgull et al. 2008; Schift et al. 2001). Numerical analysis can assist in understanding the stress evolution and the defects since the observation of microstructure is extremely difficult during cooling.

Hot embossing consists of heating a polymer substrate above its glass transition temperature, pressing a mold insert into the polymer substrate to transfer the features, cooling the substrate and mold insert while maintaining the embossing pressure, and separating the mold insert from the polymer substrate (Matthew and David 2011; Song et al. 2008a). Compared with microinjection molding, hot embossing offers advantages such as low operation cost, process simplicity, and easy mold exchange as well as replicating structures with a lower internal residual stress (Guo et al. 2007a, b; Song et al. 2008b; Worgull et al. 2008).

Numerical analyses and experiments have been performed to understand the evolution of stress on a polymer substrate during molding. Dirckx et al. showed the effects of thermal stress, friction, and adhesion on the defects of the molded part (Matthew and David 2011). Adhesion and friction between the sidewall of the mold cavity and the molded part played a significant role during demolding.

Thermal shrinkage and adhesion forces were analyzed by the finite element method (FEM) to decrease the thermal stress of molded structures (Guo et al. 2007a, b). The deformation of microstructures typically occurred in both the cooling and demolding steps. Numerical simulations estimated the friction force generated by adhesion and thermal stress (Guo et al. 2007a; Song et al. 2008b). Thermal stress was correlated with the geometry of a mold cavity, and auxiliary structures on the molded part were suggested as thermal stress barriers (Worgull et al. 2006; Farshchian et al. 2012).

²Department of Engineering Technology, Texas State University, San Marcos, TX 78666, USA



^{*} Correspondence: by12@txstate.edu

¹Materials Science, Engineering, and Commercialization Program, Texas State University, San Marcos, TX 78666, USA

In this paper, the stress evolution of a molded structure was studied during the cooling process of hot embossing. Numerical analysis was performed using the commercial finite element method software DEFORM-2D (Scientific Forming Technologies Corp., Columbus, OH, USA). A hemisphere-tipped post used in previous microassembly studies was selected as an example structure for the numerical analysis. Hot embossing experiments were also performed to verify simulation. The results of simulation and experiments showed the defects that resulted from thermal stress of the post.

Numerical analysis

DEFORM-2D has been used in hot embossing simulations (Farshchian et al. 2012; You et al. 2009; Jin et al. 2009). The flow of polymer was assumed as a non-Newtonian viscous fluid in demolding. The flow stress-polymer temperature relationship was described by a segmented linearization obtained from experimental data (Juang et al. 2002a, b). Flow stress of the polymer was defined as the function of stress and strain under constant strain rates. Equation 1 defines the flow behavior of the polymer at given molding temperatures and embossing forces:

$$\sigma = cT + \varepsilon^k \tag{1}$$

where σ is the flow stress, T is the molding temperature, ε is the strain rate, and c and k are the coefficients for the molding temperatures.

Heat transfer between the boundaries of the polymer substrate, the mold insert, and the substrate plate were defined as thermal conductivity in the numerical analysis as represented in Equation 2. Equation 2 defines the heat transfer rate between objects in thermal contact:

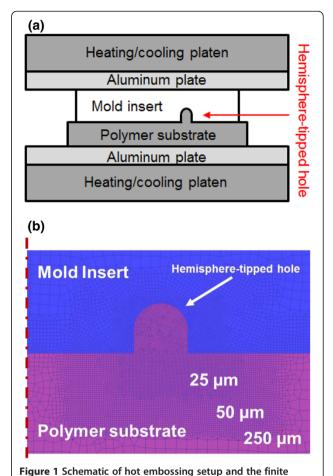
$$q_{\rm cond} = -C_{\rm cond} \frac{\partial T}{\partial X} \tag{2}$$

where $q_{\rm cond}$ is the heat flux generated by conduction, $C_{\rm cond}$ is the thermal conductivity coefficient, and $\frac{\partial T}{\partial X}$ is the temperature gradient.

The effect of heat transfer between the environment and the polymer substrate was considered by convection as presented in Equation 3. Equation 3 defines convection cooling as the heat transfers relative to the difference in temperatures between the polymer substrate and the environment:

$$\frac{dq_{\text{conv}}}{dt} = h A \left(T(t) - T_{\text{env}} \right) = h A \Delta T(t)$$
(3)

where $q_{\rm conv}$ is the heat transfer associated with convection, h is the heat transfer coefficient, A is the surface area, T is the substrate temperature, $T_{\rm env}$ is the temperature of the environment, and $\Delta T(t)$ is the time-



element model for the cooling process of hot embossing.

(a) Schematic of the hot embossing setup and (b) finite element model for the cooling process of hot embossing.

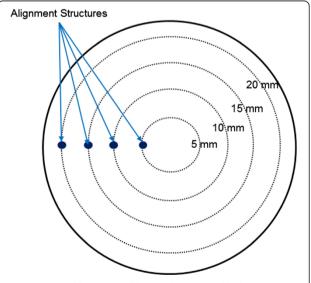


Figure 2 Radial locations of hemisphere-tipped holes on an embossed part.

Table 1 Material and process parameters in experiments

Material	PMMA
Density (10 ³ kg/m ³)	1.19
Tg (°C)	108
Embossing temperature (°C)	150
Cooling time (s)	900
Demolding temperature (°C)	85

dependent thermal gradient between the environment and the polymer substrate.

A schematic of the hot embossing setup and the finite element model for numerical analysis are shown in Figure 1. Figure 1a represents the typical hot embossing configuration for simulation. The cooling process of the hot embossing was modeled as a non-isothermal and axis-symmetric system as shown in Figure 1b. A mold insert had hemisphere-tipped holes corresponding to a hemisphere-tipped post. The alignment structure, a hemisphere-tipped post, had a depth of 952 μm and a radius of 500 μm .

The mold insert, the aluminum plates, and the platens were considered as rigid bodies. The polymer substrate was considered an elasto-plastic body. Heat exchange boundaries were included to the mold insert, aluminum plates, and polymer substrate to allow heat transfer between thermal contacts and the environment. It was assumed that the polymer flows identically in any cross-sectional area on the *X*- and *Y*-planes. A non-slip condition was applied on the bottom surface of the polymer substrate.

The simulation model included 9,700 four-nodal elements for the polymer substrate. The element size decreased from 250 to 25 μm as the polymer substrate reached the boundary of the hemisphere-tipped hole. During cooling, the mold temperature was decreased from 150°C to 85°C. A cooling time of 900 s was considered in the numerical simulations.

Four radial locations of the post at 5, 10, 15, and 20 mm from the center of the mold insert were considered to evaluate whether the radial location of the post had an effect on the stress evolution as shown in Figure 2. The polymer substrate was assumed to completely fill the hemisphere-tipped hole. Thus, the cooling step will initiate from the assumption that the mold cavity is completely filled.

Experiments

A Carver thermal press (AutoFour/15-NE, Carver, Inc., Wabash, IN, USA) was used for hot embossing experiments. The mold insert, having hemisphere-tipped holes,

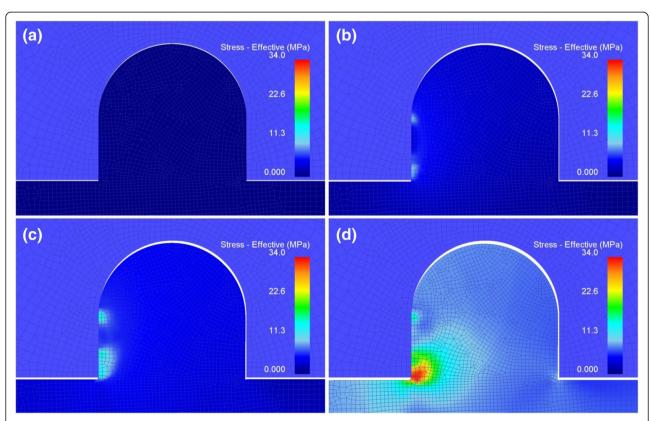


Figure 3 Stress evolution of the post located 5 mm from the thermal center during cooling. (a) Cooling time of 1.1 s, (b) cooling time of 5.1 s, (c) cooling time of 10.6 s, and (d) cooling time of 56.1 s.

was mounted at the center of the upper aluminum plate. The polymer substrate was placed on the lower aluminum plate during molding. Poly(methyl methacrylate) (PMMA) sheets (Plexiglass $^{\circ}$, Sabic Plastics, Shanghai, China) were selected as the substrate material. The thickness of PMMA was 4.5 ± 0.5 mm. The glass transition temperature of PMMA is about 105 $^{\circ}$ C. Prior to embossing, the polymer substrates were dried in a convection oven (31-350ER-1, Quincy Lab, Chicago, IL, USA) for 4 h.

Material and process conditions applied in the experiments are shown in Table 1. Molding temperature was $150^{\circ}\text{C} \pm 5^{\circ}\text{C}$, embossing force was 600 N, cooling time was 900 s, and demolding temperature was $85^{\circ}\text{C} \pm 5^{\circ}\text{C}$. Scanning electron microscopy (SEM; Helios NanoLab 400, FEI, Hillsboro, OR, USA) was used to take the image of molded structures.

Results and discussion

Numerical analyses were performed to investigate the stress evolution of the embossed post during cooling. The results of these analyses were represented by effective stress of the molded posts at cooling times of about 1, 5, 10, and 55 s. Different colors represent the distribution of effective stress of the post.

Figure 3 shows the stress of the post located 5 mm from the center of the part. The shrinkage of the part began from the top surface of the hemisphere-tipped post with the cooling of polymer as shown in Figure 3a. The stress in the post was developed along the left sidewall of the mold cavity at a cooling time of 5.1 s as shown in Figure 3b. The post was separated from the right sidewall of the mold cavity as the shrinkage of polymer increased. Figure 3c shows the stress concentration on both the top and bottom of the sidewall of the post with the cooling time of 10.6 s. The maximum stress of 33.3 MPa was observed in the vicinity of the bottom edge of the post following the direction of the thermal center when the cooling time was 56.1 s as shown in Figure 3d.

The stress developed in the post, located 20 mm along the radial direction of the part, is shown in Figure 4. The increase in radial distance of the post from the center induced a higher stress to push the post in the opposite direction of the shrinkage of polymer. This caused the inclination of the post as shown in Figure 4d. The stress was concentrated on the left bottom edge and it expanded further into the post as the cooling time increased. This resulted in the undercut of the post at its bottom edges. The maximum stress of 34.6 MPa was estimated at a cooling time of 55.5 s.

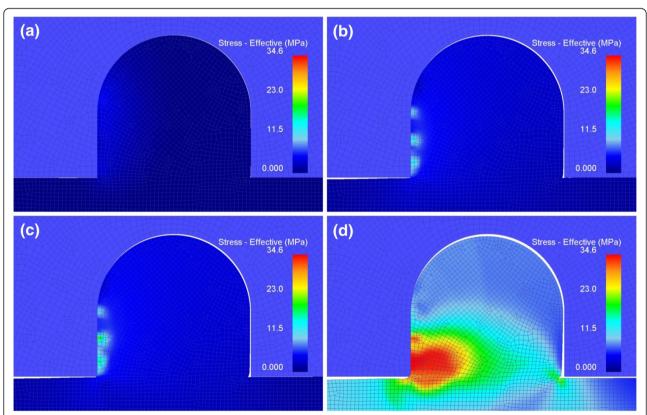


Figure 4 Flow stress of the alignment structure located 20 mm from the thermal center during cooling. (a) Cooling time of 1.0 s, **(b)** cooling time of 5.0 s, **(c)** cooling time of 10.2 s, and **(d)** cooling time of 55.5 s.

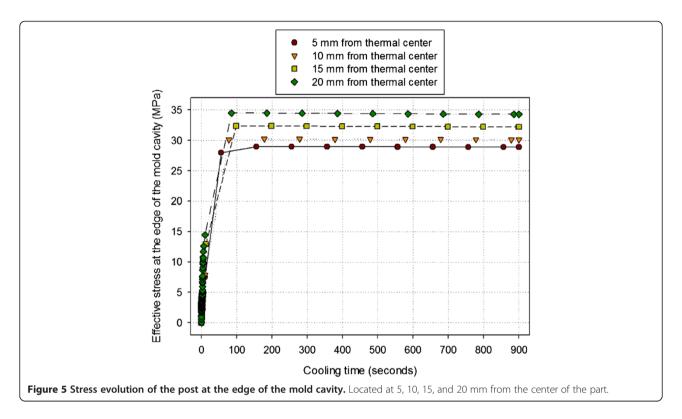
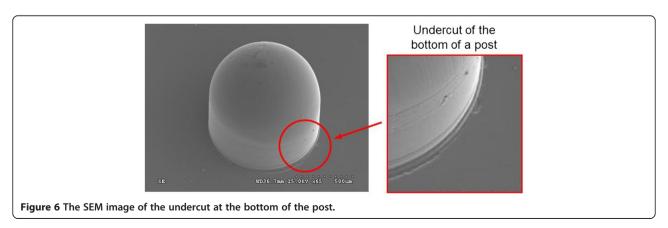


Figure 5 shows that the stress evolution of the post is significantly correlated with the radial locations of the post from the center of the embossed part during cooling. The stress of the post was estimated at the edge of the mold cavity. With the increase of the radial distance of the post, the stress increased. During the first 100.0 s into the cooling step, the accelerated heat loss caused elevated effective stress on the embossed pattern. This could be explained by the thermal shrinkage generated during this period. Thermal shrinkage induced rapid increase of stress by pushing the embossed pattern into the left sidewall of the mold cavity due to the difference in thermal expansion between the mold insert and the polymer substrate. The maximum stresses were 28.9, 30.2, 32.3, and 34.5 MPa while the posts were located

at 5, 10, 15, and 20 mm from the center of the part, respectively.

From the numerical analysis, when the embossed part was cooled, it shrank from the edge toward the thermal center of the embossed part but the sidewall of a mold cavity contacting the post prevented its shrinkage. This caused thermal stress and stress concentration in the post. As the distance between the posts and thermal center increased, thermal stresses also increased since they were proportional to the amount of shrinkage of the embossed part.

Experiments were performed to validate the numerical analysis for the stress developed in the posts during cooling of hot embossing. However, the observation of cooling of the post is considered to be difficult since it



requires monitoring the polymer inside the hemispheretipped hole of the mold insert. However, the defect predicted in numerical analysis can be used to validate the numerical models. The defect was observed using SEM. Figure 6 shows a SEM image of the embossed post. The undercut at the bottom of a post is evident as it was predicted in Figure 4d.

Conclusions

The stress evolution in the cooling of hot embossing was investigated for the replication of microstructures. A numerical analysis was performed to study the stress developed in the hemisphere-tipped post during cooling. Finite element models, using DEFORM-2D, predicted stress concentration at the bottom edge of the post. The results of the analysis showed that the maximum stresses were 28.9, 30.2, 32.3, and 34.5 MPa while the posts were located at 5, 10, 15, and 20 mm from the center of the part, respectively. The stress rapidly increased until the cooling time reached about 100.0 s. As the radial distance of the post from the thermal center increased, thermal stresses also increased. Hot embossing experiments were conducted to validate the numerical models. The undercut at the bottom of a post is observed as it was predicted in the numerical analysis. The developed models were applicable to the design of the cooling process of micro hot embossing.

Competing interests

The authors declare that they have no competing interests.

Authors' contributions

JAG carried out the numerical analysis, designed micro hot embossing experiments, and participated in the analysis of results for the manuscript. DL assisted experimental testing and manuscript revisions. I-HS participated in the design and coordination of micro hot embossing experiments. BHY conceived the study and drafted the manuscript. All authors read and approved the final manuscript.

Received: 5 May 2014 Accepted: 26 September 2014 Published online: 11 November 2014

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doi:10.1186/s40712-014-0020-9

Cite this article as: Gomez et al.: Study on stress evolution in the cooling process of micro hot embossing. International Journal of Mechanical and Materials Engineering 2014 9:20.

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